

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

HADA et al.

Atty. Ref.: LSN-2635-208

Serial No. 10/813,442

TC/A.U.: 1795

Filed: March 31, 2004

Examiner: Kaj K. Olsen

For: GAS CONCENTRATION DETECTING APPARATUS

\* \* \* \* \*

October 29, 2007

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Sir:

Attention is directed to the attached Japanese Office Action (with English translation) in a counterpart of this application and to a copy of each non-US patent document newly cited therein. A Form PTO/SB/08a is attached.

Official citation and consideration of each identified document is requested.

Respectfully submitted,

**NIXON & VANDERHYE P.C.**

By: /Larry S. Nixon/

Larry S. Nixon  
Reg. No. 25,640

LSN:tlm  
901 North Glebe Road, 11th Floor  
Arlington, VA 22203-1808  
Telephone: (703) 816-4000  
Facsimile: (703) 816-4100